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Bib Data Sheet

CONFIRMATION NO. 7841

SERIAL NUMBER 09/974,721	FILING DATE 10/09/2001 RULE	(CLASS 438	GROUP ART UNIT 1765		TUNIT	ATTORNEY DOCKET NO. M-11928 US	
APPLICANTS Jian Zhou, San . Hua Chu, Sarato	oga, CA;							
** FOREIGN APPLICA	A ************************************	***	`\					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY **/ ** 10/29/2001								
met Allowance COUNTRY Verified and Acknowledged Examiner's Signature Initials				SHEE DRAW 6	VING	TOTAL CLAIMS 23		INDEPENDEN CLAIMS 7
Skjerven Morrill MacPherson LLP Suite 700 25 Metro San Jose , CA 95110								
TITLE Method for automatic de-skewing of multiple layer wafer for improved pattern recognition								
RECEIVED No	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:				All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit			